

UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE WASHINGTON, D.C. 2023 1

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MAY 1 2 2004

In re Application of

Choi, Chul-Hwan et al

Serial No. 10/046282

Filed: January 16, 2002

For: RE

RESIDUAL GAS REMOVING DEVICE

AND METHOD THEREOF

NOTICE OF WITHDRAWAL

FROM ISSUE

UNDER 37 CFR 1.313

The above-identified application is withdrawn from issue after payment of the issue fee due to reopening of prosecution. See 37 CFR 1.313. (b).

The above-identified application is hereby withdrawn from issue to permit reopening. An office action from the examiner will follow in due course.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon written request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Blaine Copenheaver at (571) 272-1156.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including notifying applicant of the new status of this application.

Jacqueline Stone, Director

Technology Center 1700

motore

Chemical and Materials Engineering

VOLENTINE FRANCOS, P.L.L.C. Suite 150 12200 Sunrise Valley Drive

Reston VA 20191

CC: Allowed Files